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Author: Mahbobeh Ravankhah Hadi Savaloni



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Influence of deposition angle on the structural, morphological and optical properties of sputtered AlN thin films

Mahbobeh Ravankhah and Hadi Savaloni*

Department of Physics, University of Tehran, North-Kargar Street, Tehran, Iran

*Correspondence: <u>savaloni@khayam.ut.ac.ir;</u> Tel.: +98 21 88635776; fax: +98 21 88004781.

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